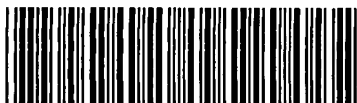


**Search Notes**

Application/Control No.

10/639,052

Examiner

Tadesse Hailu

Applicant(s)/Patent under  
Reexamination

KATANO, SEIICHI

Art Unit

2173

**SEARCHED**

Class	Subclass	Date	Examiner
715	744-748	5/3/2007	TH
715	740, 866	5/3/2007	TH
715	738, 736	5/3/2007	TH
715	762-765	5/3/2007	TH

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
715	744-748	5/3/2007	TH
715	736, 738	5/3/2007	TH
715	762-765	5/3/2007	TH
PGPUB - CLM searched - search history enclosed		5/3/2007	th

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST - Searched all databases (USPAT, PGPUB, IBM-TDB, DERWENT, EPO,&JPO)	5/3/2007	TH
google.com - searched forcustomization OR customizing "mutifuction peripherals" OR multi function peripherals OR MFP ...	5/3/2007	TH